

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/521,733	FUJISAWA ET AL.	
Examiner	Art Unit	_
David Buttner	1712	

	SEARCHED				
Class	Subclass	Date	Examiner		
NONE					
	i				
	, , ,				

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
west	9/10/2007	DB		
east	9/10/2007	DB		
chem ab	9/10/2007	DB		
inventor search	9/11/2007	DB		
7 1		· · · · · · · · · · · · · · · · · · ·		